UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
United States Patent and Trademark Office
Address: COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, Virginia 22313-1450
www.uspto.gov

CONFIRMATION NO. 2202

Bib Data Sheet

SERIAL NUMBER 10/512,022	FILING OR 371(c) DATE 10/19/2004 RULE	CLASS 117	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 93120

APPLICANTS

Tetsuhiro Iida, Hiratsuka-shi, JAPAN;
Yutaka Shiraishi, Hiratsuka-shi, JAPAN;
Ryota Suewaka, Hiratsuka-shi, JAPAN;
Junsuke Tomioka, Hiratsuka-shi, JAPAN;

** CONTINUING DATA **************************
This application is a 371 of PCT/JP03/04868 04/17/2003

** FOREIGN APPLICATIONS ********************
JAPAN 2002-118281 04/19/2002

Foreign Priority claimed ☐ yes ☐ no				
35 USC 119 (a-d) conditions met ☐ yes ☐ no ☐ Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 8	TOTAL CLAIMS 16	INDEPENDENT CLAIMS 7
Verified and Acknowledged Examiner's Signature Initials				

ADDRESS
24628

TITLE
Single crystal silicon producing method, single crystal silicon wafer producing method, seed crystal for producing single crystal silicon, single crystal silicon ingot, and single crystal silicon wafer

FILING FEE RECEIVED 1432	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	☐ All Fees
		☐ 1.16 Fees (Filing)
		☐ 1.17 Fees (Processing Ext. of time)
		☐ 1.18 Fees (Issue)
		☐ Other _____
		☐ Credit